IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

| In re Application of: | |) | PATENT APPLICATION |
|-----------------------|--|-----------------------|--|
| Inventors: | David Russell Evans |))) | May 2, 2001 |
| Serial No.: | 09/270,606 |)) | Attorney Docket No. SLA 587 (SMT 335) |
| Filed: | March 17, 1999 |) | Group No.: 1765 |
| Title: | METHOD FOR MODIFICATION OF POLISHING PATTERN DEPENDENCE IN CHEMICAL MECHANICAL POLISHING |))))) | Examiner: M. Anderson |

PETITION FOR EXTENSION OF TIME UNDER 37 C.F.R. § 1.136

Box CPA Assistant Commissioner for Patents Washington, D.C. 20231

Sir:

In the Office Action dated November 3, 2000 in the aboveidentified application, a shortened period for response was set to expire on February 3, 2001.

Pursuant to 37 C.F.R. § 1.136(a), applicant hereby petitions the Commissioner for a three-month extension of time, extending the period for Response to the Office Action up to and including May 3, 2001.

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A deposit account authorization covering the petition fee of \$890.00 (large entity) set by 37 C.F.R. § 1.17 is provided below.

X Please charge Deposit Account No. 19-1457 in the amount of \$<u>890.00</u>
 to cover the cost of the three-month extension of time.
 A duplicate copy of this authorization is enclosed.

X The Commissioner is hereby authorized to charge any additional fees, or credit any overpayment, associated with this communication to Deposit Account No. 19-1457. A duplicate copy of this authorization is enclosed.

Respectfully submitted,

Date: May 2, 2001

Matthew D. Rabdau Reg. No. 43,026

Matthew D. Rabdau, Patent Attorney Sharp Laboratories of America, Inc. 5750 Pacific Rim Boulevard Camas, WA 98607

Telephone:

(360) 834-8567

Facsimile:

(360) 817-8505